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PATENT

IN THE UNITED STATES PAT	ENT AND TRADEMARK OFFICE
In re the application of:	)
a twoopa . I	) Group Art Unit: 1746
Carl WOODS et al.	) Examiner: Unassigned
Application No. 10/817,133	) Examiner. Onassigned
••	) Atty. Docket No. LAM2P475
Filed: April 1, 2004	) Date: July 17, 2006
For: PROXIMITY MENISCUS MANIFOLD	
	) CERTIFICATE OF MAILING
	I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope
	addressed to: Commissioner for Patents, Alexandria, VA 22313-
	1450 on July 17, 2006.
	Signed:Sulvia Castillo

## INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449, (the copies of references which are not U.S. Patents have been attached), may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97. The Examiner is requested to consider these references and to acknowledge such consideration by initialing the appropriate location on the attached PTO Form 1449.

This Information Disclosure Statement (IDS) is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This IDS is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this IDS. However, if it is determined that any fees are due, then the Commissioner is hereby authorized to charge such fees to Deposit Account 50-0805 (Order No. LAM2P475).

Respectfully submitted,

MARTINE PENILLA & GENCARELLA, LLP

Albert S. Penilla, Esq. Rog. No. 39,487

710 Lakeway Drive, Suite 200 Sunnyvale, CA 94085 Telephone: (408) 774-6903 Customer Number 25920 JUL 2 1 2006 USe as many

# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

of

Complete if Known					
Application Number	10/817,133				
Filing Date	April 1, 2004				
First Named Inventor	WOODS et al.				
Art Unit	1746				
Examiner Name	Unassigned				
Attorney Docket Number	LAM2P475				

### **U.S. Patent Documents**

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Examiner (	Cite	Document Number	Publication Date	Name of Patentee or Applicant of Cited	Pages, Columns, Lines, where Relevant			
Initials	No. <sup>1</sup>	Number-Kind Code <sup>2 (if known)</sup>	MM-DD-YYYY	Document	Passages or Relevant Figures Appear			
	Α	2003/0092264 A1	05/15/03	Shinji et al.				
	В	2004/0060573 A1	04/01/04	Woods				
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		Country Code <sup>3</sup> -Number- <sup>4</sup> Kind Code <sup>5(if known)</sup>			Figures Appear	
	М	EP 1 489 461 A1	12/22/04	ASML Netherlands B.V.		
	N	EP 1 489 462 A2	12/22/04	ASML Holding N.V.		

#### **Non Patent Literature Documents**

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Examiner Initial	Cite No.	Include name of author (in CAPTIAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
	0	OWA et al. "Immersion lithography; its potential performance and issues", Proceedings of the SPIE, SPIE, Bellingham, VA, US, Vol. 5040, No. 1, February 28, 2003, pages 724-733, XP002294500
,	P	LIM et al., "Atomic Layer deposition of transition metals", Department of Chemistry and Chemical Biology, Harvard University, Nature Publishing Group, Volume 2, November 2003, Pages 749-754

Examiner	Date
Signature	Considered

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	В	3,953,265	04/27/76	Hood	
	С	4,367,123	01/04/83	Beck	
	D	4,444,492	04/24/84	Lee	
	Ε	5,102,494	04/07/92	Harvey et al.	
	F	5,180,431	01/19/93	Sugimoto et al.	
	G	5,343,234	08/30/94	Kuehnle	
	Н	5,361,449	11/08/94	Akimoto	
	ī	5,472,502	12/05/95	Batchelder	
	J	5,558,111	09/24/96	Lofaro	
	K	5,601,655	02/11/97	Bok et al.	
	L	5,709,757	01/20/98	Hatano et al.	

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		Country Code <sup>3</sup> -Number- <sup>4</sup> Kind Code <sup>5(if known)</sup>			Relevant Figures Appear	
	М	JP11031672 (Patent Abstract in English provided)	02/02/99	Hitachi Ltd.		
	N	WO 03/014416 A2	02/20/03	Ebara Corporation		

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	0	ICKnowledge LLC, "Technology Backgrounder: Atomic Layer Deposition", ICKnowledge.com, 2004, Pages 1-7
	Р	"Chemical vapor deposition", Wikipedia, the free encyclopedia, http://en.wikipedia.org/wiki/Chemical_vapor_deposition, 2005, Page 1-2

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	В	6,092,937	07/25/00	Snodgrass et al.					
	С	6,103,636	08/15/00	Zahorik et al.					
	D	6,108,932	08/29/00	Chai					
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	L	6,550,988	04/22/03	Sugimoto et al.					

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		Country Code <sup>3</sup> -Number- <sup>4</sup> Kind Code <sup>5(if known)</sup>			Relevant Figures Appear	
	М	WO 99/49504	9/30/99	Nippon Kogaku KK		
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	0	SIGMA-ALDRICH, "Atomic Layer Deposition (ALD)", <a href="http://www.sigmaaldrich.com/Area of Interest/Chemistry/Materials Science/Thin Films">http://www.sigmaaldrich.com/Area of Interest/Chemistry/Materials Science/Thin Films</a> , 2005, Pages 1-2		
	Р			

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		Number-Kind Code <sup>2 (if known)</sup>	MM-DD-YYYY	Document	Figures Appear			
	Α	6,555,017	04/29/03	Rushford et al.				
	В	6,616,772	09/09/03	De Larios et al.				
	С	6,854,473	02/15/05	Hanson et al.				
	D	6,954,993	10/18/05	Smith et al.				
	E	6,988,326	01/24/06	O'Donnell et al				
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